



Attorney's Docket No.: 042390P6958

Patent

#9/B
2/16/07

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Anne E. Miller et al.

U.S. Serial No: 09/461,158

Examiner: Brown, C.

COPY OF PAPERS
ORIGINALLY FILED

Filed: December 14, 1999

Art Unit: 1765

For: HIGH PH SLURRY FOR
CHEMICAL MECHANICAL
POLISHING OF COPPER

Assistant Commissioner for Patents
and Trademarks
Washington, D.C. 20231

RECEIVED
FEB 04 2002
TC 1700

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed May 9, 2001. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

on November 8, 2001
Date of Deposit

Teresa Edwards

Name of Person Mailing Correspondence

Teresa Edwards

Signature

November 8, 2001

Date